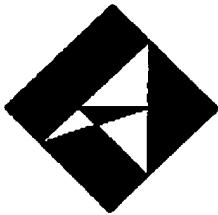


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## facsimile transmittance

**To:** Examiner Erik J. Kielin      **Fax:** 703-872-9319  
**From:** Mag Chappuis      **Date:** June 19, 2003  
**E-mail:** Mchappuis@atmi.com      **Pages:** 30  
**Re:** Response to Final Office Action in      **cc:**  
United States Patent Application No.  
09/823,196

**RESPONSE TO MARCH 27,2003 FINAL OFFICE ACTION IN UNITED  
STATES PATENT APPLICATION NO. 09/823,196**

Dear Examiner Kielin:

Please find the following documents enclosed:

**Response to March 27, 2003 OA – 13 sheets**  
**Appendix A including cover – 10 sheets**  
**Appendix B including cover – 4 sheets**  
**Appendix C including cover – 2 sheets**  
**Transmittal – 1 sheet**

Please call 203-794-1100 ext. 4184 if there are any problems with this transmittal.

Maggie Chappuis

ATMI, Inc.  
7 Commerce Drive  
Danbury, CT 06810  
203-794-1100 (telephone)  
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ATMI Docket: ATM-510

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U.S. Patent Application No. 09/823,196

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#15/B  
Am 3d  
N/E  
J. Macmillan  
7/12/03

In re United States Patent Application of:

Applicants:	Thomas H. Baum et al.
Serial No.:	09/823,196
Date Filed:	March 30, 2001
Title:	SOURCE REAGENT COMPOSITIONS FOR CVD FORMATION OF GATE DIELECTRIC THIN FILMS USING AMIDE PRECURSORS AND METHOD OF USING SAME

Docket No.: ATMI-510  
Examiner: Erik J. Kielin  
Art Unit: 2813  
Customer No.: 25559

## FACSIMILE TRANSMISSION CERTIFICATE

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Maggie Chappuis  
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RESPONSE TO MARCH 27,2003 FINAL OFFICE ACTION IN UNITED STATES  
PATENT APPLICATION NO. 09/823,196

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 27, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.

DO NOT ENTER 7/14/03

ERK